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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/653,157  
Filing Date ..... August 31, 2000  
Inventor ..... Torek et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1765  
Examiner ..... Deo  
Attorney's Docket No. .... MI22-1376  
Title: Methods of Removing at Least Some of a Material from a Semiconductor Substrate

RESPONSE TO OCTOBER 22, 2002 OFFICE ACTION

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

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AMENDMENTS

In the Claims

None.

